

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: FUJISAWA et al.
Filed: July 3, 2003
For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
(AS AMENDED)

PRELIMINARY AMENDMENT

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 3, 2003

Sir:

Please amend the above-identified application, prior to examination thereof,
as follows:

IN THE SPECIFICATION

Please delete the original title in its entirety, and substitute therefor the
following new title:

--METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE--.

Page 1, between the title and the heading "BACKGROUND OF THE
INVENTION", please insert the following new paragraph:

--This application is a Continuation of Application No. 10/214,313, filed
August 8, 2002, which is a Continuation of Application No. 09/594,046, filed
June 15, 2000, which is a Divisional of Application No. 09/126,438, filed
July 30, 1998, now U.S. Patent No. 6,232,650, issued May 15, 2001, the entire
disclosure of No. 09/126,438 being incorporated herein by reference.--